et No.: 10473-784

FEB 2 6 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Customer Number: 20277

Dennis G. THIBEDEAU, et al.

Confirmation Number: 9489

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PATENT

Serial No.: 09/888,385

Group Art Unit: 2858

MAR 0 2 2004

Filed: June 26, 2001

Examiner: A. He

For:

ALTERNATOR TESTING METHOD AND SYSTEM USING RIPPLE DETECTION

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

Applicant is entitled to small entity status under 37 CFR 1.27

Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	30	30	0	\$18.00 =	\$0.00
Independent Claims	8	8	0	\$86.00 =	\$0.00
		Multiple claims newly presented			\$0.00
		Fee for extension of time		\$0.00	
		24			\$0.00
• .		Total of Above Calculations			\$0.00

Please charge my Deposit Account No. <u>500417</u> in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Wei-Chen Chen

Recognized under 37 CFR §10.9(b)

600 13th Street, N.W. Washington, DC 20005-3096 (202) 756-8000 WC:apr Facsimile: (202) 756-8087 Date: February 26, 2004



BEFORE THE OFFICE OF ENROLLMENT AND DISCIPLINE UNITED STATE PATENT AND TRADEMARK OFFICE

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LIMITED RECOGNITION UNDER 37 CFR □ 10.9(b)

This document constitutes proof of such recognition. The original of this document is on file in the Office of Enrollment and Discipline of the U.S. Patent and Trademark Office.

Expires: March 1, 2004

Harry I. Moatz

Director of Enrollment and Discipline